

**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITING PROCEDURE
EXAMINING GROUP 1700**

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To Examiner:	George A. Goudreau	Total Pages Sent:	14
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chen, *et al.* Docket No.: TSM6283131RI
 Serial No.: 10/650,886 Art Unit: 1763
 Filed: August 28, 2003 Examiner: George A. Goudreau
 For: In-Situ Strip Process for Polysilicon Etching in Deep Sub-Micron Technology

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I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office on the date shown above:

- Certification of Facsimile Transmission (1 page)
- Response to Final Office Action under 37 C.F.R. § 1.116 (13 pages)

Respectfully submitted,

Judy A. Betts
Legal Assistant

Confirmation Respectfully Requested

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RESPONSE TO FINAL OFFICE ACTION UNDER 37 CFR § 1.116

Dear Sir:

Applicant respectfully submits the following amendment and remarks in response to the Final Office Action dated February 18, 2005. Applicant respectfully requests that this amendment and remarks be entered pursuant to the provisions of 37 CFR § 1.116, as it is believed that this amendment is fully responsive to Examiner's rejections and places the application in condition for allowance.

TSM6283131RI

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